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#### FACSIMILE COVER SHEET

TO:

Examiner Long Pham

U.S. Patent & Trademark Office

Group Aft Unit 2814

FROM:

Damond E. Vadnais, Reg. No. 52,310

RE:

U.S. Application No. 10/657,269 Atty. Docket No.: 03500.016072.1

FAX NO.:

(571) 273-8300

DATE:

January 17, 2006

NO. OF PAGES: (including cover page)

10

TIME:

5; 38 P.M.

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4:5

#### MESSAGE

#### Attachments:

- 1) Amendment and Request for Interview Transmittal
- 2) Amendment and Request for Interview

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JAN 17 2006

In re Application of:

Docket No. 03500.016072.1

MINEO SHIMOTSUSA, et al.

Application No.: 10/657,269

Examiner: Long Pham

Filed: September 9, 2003

Group Art Unit: 2814

For: SEMICONDUCTOR DEVICE, METHOD FOR MANUFACTURING THE SAME,

Date: January 17, 2006 (the first

business day following the

AND LIQUID JET APPARATUS

ATUS Martin Luther King, Jr. Holiday)

Mail Stop Amendment THE COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment and Request for Interview in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED							
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	<b>*</b> 4	MINUS	** 35	= 0	x \$25 \$50	\$0	
INDEP. CLAIMS	* 1	MINUS	***	= 0	x \$100 \$200	\$0	
Fee for Mu	\$0						
	\$0						

<sup>\*</sup> If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

\*\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

<sup>\*\*</sup> If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

	Verified Statement claiming small entity status is enclosed, if not filed previously.				
	A check in the amount of \$ is enclosed.				
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.				
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205.				
	A check in the amount of \$ to cover the fee for a month extension is enclosed.				
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.				
X	Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.				
	Respectfully submitted,				
	Damond E. Vadnais Attorney for Applicants Registration No.: 52 310				

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

Form #120

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03500.016072.1

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  MINEO SHIMOTSUSA, et al.  Application No.: 10/657,269		Examiner: Long Pham		
		Group Art Unit: 2814		
		<b>√</b>		
Filed: September 9, 2003	) :			
For: SEMICONDUCTOR DEVICE, METHOD FOR MANUFACTURING THE SAME, AND LIQUID JET APPARATUS	);;	January 17, 2006 (the first business day following the Martin Luther King, Jr. Holiday)		
Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450				

# AMENDMENT AND REQUEST FOR INTERVIEW

Sir:

In response to the Office Action dated October 14, 2005, please amend the above-identified application, as follows:

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Damond E. Vadnais, Reg. No. 52,310

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